Search Notes

Application/Control No.	Applicant(s)/Patent under Reexamination	
10/809,203	HIRAI, TOSHIMITSU	
Examiner	Art Unit	
Su C. Kim	2823	

SEARCHED						
Class	Subclass	Date	Examiner			

INI	INTERFERENCE SEARCHED					
Class	Subclass	Date	Examiner			
		<u></u>				

)
DATE	EXMR
12/26/2006	SK
12/26/2006	sĸ
:	